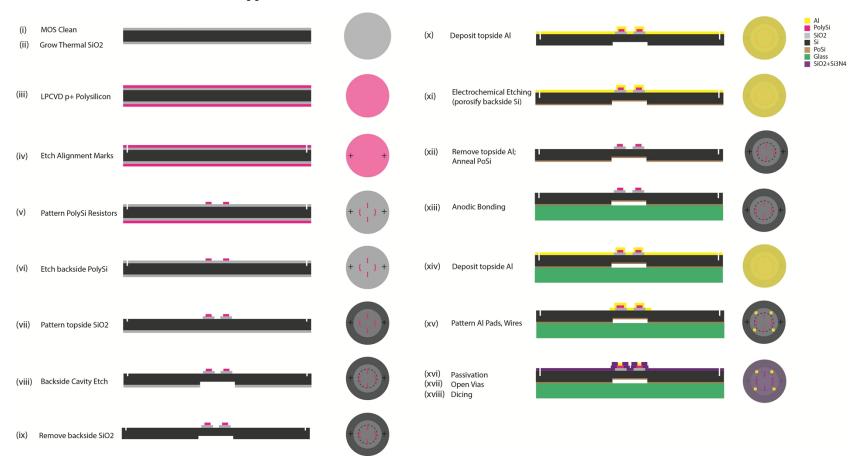
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Supplemental Section 1 – Microtensiometer Fabrication Process Flow

Fig. S1 Microtensiometer fabrication process flow (full). Wafer cross-sectional view (left side), top view (right side).